


Search Notes 	Application/Control No. 10784170	Applicant(s)/Patent Under Reexamination BACK, DAE-WHAN
	Examiner Ryan C. Kavleski	Art Unit 2475

SEARCHED			
Class	Subclass	Date	Examiner
370	351, 216, 431, 248, 254	12/9/08	RK
ABOVE	UPDATED	4/8/09	RK
ABOVE	UPDATED	10/9/09	RK
ABOVE	UPDATED	12/28/09	RK
ABOVE	UPDATED	6/27/10	RK
ABOVE	UPDATED	9/13/10	RK

SEARCH NOTES			
Search Notes		Date	Examiner
EAST Based Search		12/8/08 (updated on 9/13/10)	RK
PLUS Based EAST Search		12/9/08 (updated on 4/9/09)	RK
Consulted Primary Robert Wilson regarding secondary reference		12/28/09	RK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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